

**Notice of References Cited**

Application/Control No.

10/517,443

Applicant(s)/Patent Under  
Reexamination  
SHIMIZU ET AL.

Examiner

Jeffrey K. Wong

Art Unit

3714

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP2001-009157	07-1996	Japan	Yasushi et al.	
	O	JP2001-070651	09-1999	Japan	Koichi et al.	
	P	JP10-033821	06-1999	Japan	Osamu et al.	
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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